

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,830,652 B2
DATED : December 14, 2004
INVENTOR(S) : Tadahiro Ohmi et al.

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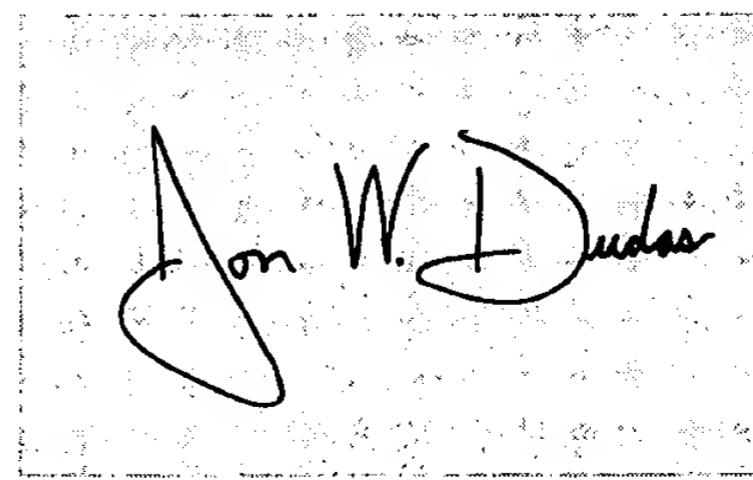
It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title page,

Item [54], Title, replace "**MICROWAVE PLASMA PROCESSING APPARATUS**" with -- **PLASMA PROCESSING APPARATUS** --.

Signed and Sealed this

Seventh Day of June, 2005



JON W. DUDAS
Director of the United States Patent and Trademark Office